

MAXSTREAM 600, 800, 1000, AND 1200

MID-FLOW CHAMBER CLEAN REMOTE PLASMA SOURCE

The MAXstream[™] 600, 800, 1000, and 1200 are reliable and cost-effective remote plasma source (RPS) solutions for mid-flow (6 to 12 SLPM) NF₃ chamber clean applications. The MAXstream has smaller footprint than the Xstream RPS unit to save valuable tool space and offers drop-in replacement capabilities for traditional RPS tools for easy integration. Market-leading power control for improved process repeatability along with AE's proprietary aluminum (AI) substrate with Type 3 hard anodization combine to make it one of the most consistent and reliable RPS product on the market.

PRODUCT HIGHLIGHTS

- Higher power and flow for maximum chamber cleaning efficiency and less production downtime for cleaning
- Industry-leading power control for consistent, repeatable performance
- Proprietary high-purity AI substrate with Type 3 anodization for longer chamber life
- Unique dual ignition core design ensures virtually 100% ignition reliability
- Drop-in compatibility with traditional RPS systems to enable simple design-in compatibility as well as seamless field upgrades to a reliable, repeatable, and low cost-of-ownership solution

TYPICAL APPLICATIONS

NF₃ chamber clean



PROCESS AND ELECTRICAL SPECIFICATIONS

Model	MAXstream 600	MAXstream 800	MAXstream 1000	MAXstream 1200	
General Operating Parameters					
Plasma Power Range	1000 to 8000 W	1000 to 9000 W	1000 to 10,000 W	1000 to 12,000 W	
Process Applications	Remote delivery of activated gases for downstream processing (i.e. chamber cleaning, reactive etching processes, and reactive deposition processes)				
Ignition	100 mTorr to 4 Torr of Argon up to 1 SLPM				
Power Accuracy	5% or 50 W, whichever is greater				
Chemical Compatibility	This unit is intended for use with selected gases such as Ar, O ₂ , N ₂ , F ₂ , H ₂ O, NF ₃ , Cl or O ₂ : CxFy				
NF ₃ Operating Specifications					
Flow Range	Up to 6 SLPM at 15 Torr	Up to 8 SLPM at 20 Torr	Up to 10 SLPM at 25 Torr	Up to 12 SLPM at 30 Torr	
Dissociation Efficiency	>96%				
Operating Specifications					
Duty Cycle	Continuous operation within specified operating range				
Cooling Flow Rate	2 GPM at 30°C input water temperature				
Ambient Air	+5°C to +40°C, non-condensing humidity < 75%				
AC Electrical Requirements					
Input Voltage	200 to 208 VAC ±10% (180 to 229 VAC), no neutral, 3 phase with PE ground (phase insensitive)				
Line Frequency	50 to 60 Hz nominal; 47 to 63 Hz range				
Input Current	< 35 A AC				

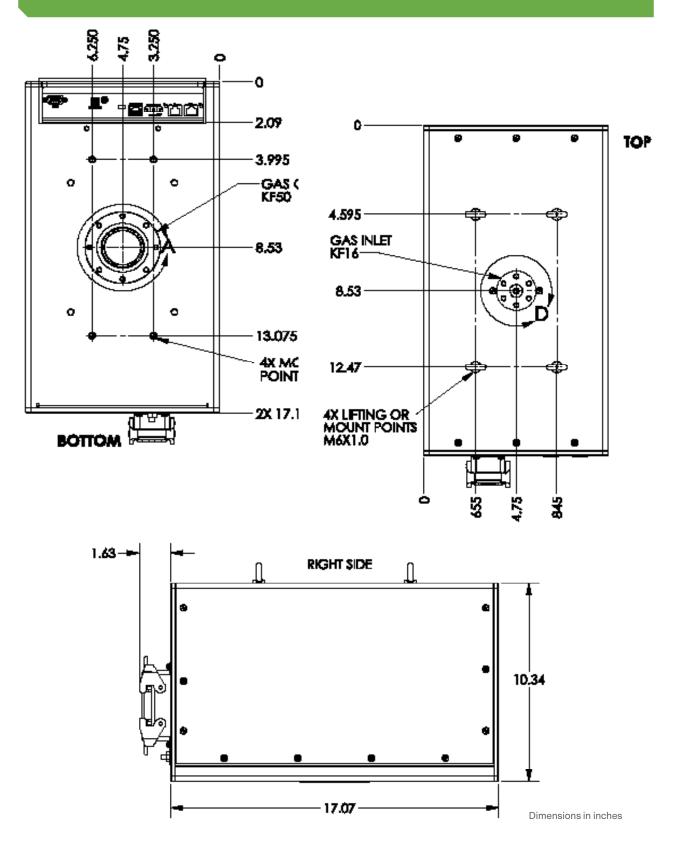
MECHANICAL SPECIFICATIONS

Mechanical and Physical Specifications		
Dimensions	26.3 cm (H) x 24.1 cm (W) x 43.4 cm (D)	
	10.3" (H) x 9.5" (W) x 17.1" (D)	
Weight	30 kg (66.1 lb)	
Vacuum	Input: KF40 flange on top side of the unit	
	Output: KF40 interface on bottom of unit	
Ground Connection	Chassis ground stud 1/4"-20 x 3/4" near AC input connector	
USB Connection	USB Type A female	
Ethercat Connection	RJ45 female	
Water Connections	Stainless steel Female SAE 9/16" – 18 straight-thread	



MAXSTREAM 600 TO 1200 REMOTE PLASMA SOURCE

MECHANICAL DRAWINGS







ABOUT ADVANCED ENERGY

Advanced Energy (AE) has devoted more than three decades to perfecting power for its global customers. AE designs and manufactures highly engineered, precision power conversion, measurement and control solutions for mission-critical applications and processes.

AE's power solutions enable customer innovation in complex semiconductor and industrial thin film plasma manufacturing processes, demanding high and low voltage applications, and temperature-critical thermal processes.

With deep applications know-how and responsive service and support across the globe, AE builds collaborative partnerships to meet rapid technological developments, propel growth for its customers and power the future of technology.







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